HOMOJUNCTION SEMICONDUCTOR DEVICE AND MANUFACTURE OF PHOTOELECTRIC CONVERSION DEVICE USING THE SAME

Patent number:

JP6097481

Publication date:

1994-04-08

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Classification:

- international:

H01L31/04

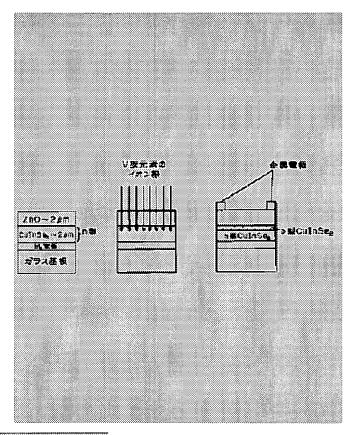
- european:

Application number: JP19920244375 19920914 Priority number(s): JP19920244375 19920914

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Abstract of JP6097481

PURPOSE:To provide a homojunction semiconductor device having an improved device characteristic, which can be matched with the semiconductor thin film made of I-III-(IV)2 chalcopyrite compound in its lattice constant, its orientation quality to substrate surface and its surface mohology and to provide a photoelectric conversion semiconductor device using the same. CONSTITUTION:On an Mo lower electrode, an element having CuInSe2, ZnO and ITO thin films is manufactured. An ionic radiation of nitrogen atom is acceleration-projected thereon, and a homojunction is formed in the CuInSe2 thin film, and thereby, a photoelectric conversion semiconductor device is created.



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